

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akinori KOUKITSU et al.

Application No.: New U.S. National Stage of
PCT/JP03/04408

Filed: September 27, 2004

Docket No.: 121213

For: VAPOR PHASE GROWTH METHOD FOR Al-CONTAINING III-V GROUP
COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR
PRODUCING Al-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR**PRELIMINARY AMENDMENT**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;**Amendments to the Claims** as reflected in the listing of claims;**Remarks.**